



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:

Teiichirou Chiba *et al.*

Serial No.: 09/492,761

Filed: January 27, 2000

For: SEMICONDUCTOR WAFER

Examiner: C. Chu

Group Art Unit: 2815

**RESPONSE AFTER FINAL UNDER 37 C.F.R. § 1.116**

Honorable Commissioner  
of Patents and Trademarks  
Washington, D.C. 20231

July 22, 2002

Dear Sir:

The following amendments and remarks are submitted in response to the Official action mailed February 21, 2002. The Official action set forth a three-month period for response, and a petition for a two-month extension of time is attached hereto, making this response to one or before July 21, 2002. Since July 21, 2002, was a Sunday, this response can be timely filed on the following business day, Monday, July 22, 2002.

Please amend the above-identified application as follows:

**IN THE SPECIFICATION:**

Please replace the paragraph beginning at page 23, line 15, with the following rewritten paragraph:

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TECHNOLOGY CENTER 2800

#12/B (NE)  
7/31/02  
Sunder

Sunder  
10/16/02

enter amendment  
a.c.  
10/2/02